

<b>FORM PTO-1449/A and B (Modified) JUN 17 2005</b>			
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		APPLICATION NO.: 10/020,004	ATTY. DOCKET NO.: H0498.70164US00
		FILING DATE: December 11, 2001	CONFIRMATION NO.: 7232
		APPLICANT: Lieber, et al.	
		GROUP ART UNIT: 2826	EXAMINER: Mandala, Victor A.
Sheet	1	of	1

#### U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM/DD/YYYY
		Number	Kind Code		
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#### OTHER ART – NON PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
VAMS		Office Action mailed 09/15/2004 in U.S. Patent Application No. 09/935,776, filed 08/22/2001	
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EXAMINER:

*Victor A. Mandala*

DATE CONSIDERED:

*8-23-05*

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

\*a copy of this reference is not provided as it was previously cited by or submitted to the office in a prior application, Serial No. 10/020,004, filed 12/11/2001, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).